# Monthly LabAdviser update: 30/8 2013

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| Updated Subject | Contributor | Link to the update pages |
| **Process2Share**  Nothing has been added.  **Come on users! You must have made something that is worth showing the other user☺** | **Let me know if you need help to add something to process2Share:** [**labadviser@danchip.dtu.dk**](mailto:labadviser@danchip.dtu.dk) | <http://process2share.danchip.dtu.dk/index.php/Main_Page> |
| **Etch rate of low stress nitride in BHF**  Has been added. | Eric Jensen @nanotech | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/Wet_Silicon_Oxide_Etch_(BHF)#Silicon_oxide_etch_data> |
| **Electroplating-Ni**  Equipment page has been made  Standard processes have been added. | Claus Højgård Nielsen @danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/Electroplating-Ni>  <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/Deposition_of_Nickel/Electroplating_of_nickel> |
| **Polymer Injection Molder**  Equipment page has been made. | Claus Højgård Nielsen @danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Back-end_processing/Polymer_Injection_Molder> |
| **Ellipsometer VASE**  Equipment page for ellipsometer VASE (new ellipsometer) has been added. | Berit G. Herstrøm@ danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Characterization/Optical_characterization#Ellipsometer> |
| **BHF**  Comparing the different BHF baths – look also at the lower half of the page. | Karen Birkelund @danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/Wet_Silicon_Oxide_Etch_(BHF)> |
| **KOH**  Updated comparison of the KOH baths. | Karen Birkelund @danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/KOH_Etch> |